

# DEVICE AND METHOD FOR A PRECISE BREAKDOWN VOLTAGE DETECTION OF APD/SPAD IN A DARK ENVIRONMENT

# **2ND INTERNATIONAL SPAD SENSOR WORKSHOP**

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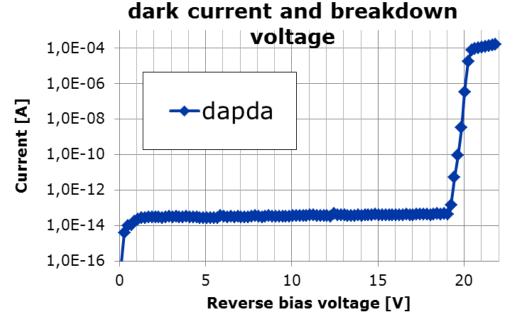
- Technical issues on breakdown voltage measurement
  - Characterization
  - Application
- Functionality principle & simulation study
- Characterization results
- Conclusions



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- > What should be the objective of this talk?
  - Is it worth to talk about the device characterization of breakdown voltage?
  - It should be a simple number extracted from a IV -curve
  - CMOS foundry point of view but there is more behind them
- Most important parameter to monitor the CMOS process
  - Shift in the breakdown voltage refer to issues in the process
- Therefore, the methodology how to extract the breakdown voltage or even the IV-curve is essential

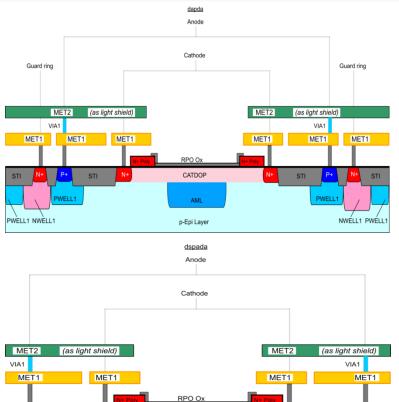


# Motivation



#### > By choosing the "AVLA" process module

- Enable the primitive device of avalanche photodiode and single photon avalanche diode
- Necessity to monitor the process for both devices
  - Main criteria breakdown voltage for both devices
- Considering with one method two aspects:
  - Avalanche Photodiode:
    - High and stable gain multiplication needed
  - Single Photon Avalanche Diode:
    - Increased voltage swing for excess voltage required



CATDOP

AML

p-Epi Layer

Name	Description	LSL	Low	Тур	High	USL	Unit
BVJ_DAVLA	Breakdown voltage @ Irev= 10 nA/ $\mu$ m <sup>2</sup> , T= 27 °C	18.9	19.25	19.6	19.95	20.3	V

STI

STI

PWELL1

P+

PWELL1

STI

STI



#### Motivation

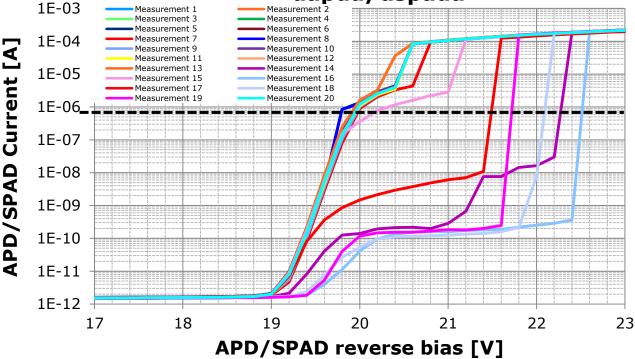
#### Technical issues on breakdown voltage measurement

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# State of the art BV measurement for primitive devices

- With current measurement principle it is very challenging to define <u>one</u> breakdown voltage value for avalanche photodiodes
- Not the appropriate measurement methodology
  - Need to consider timing dependency





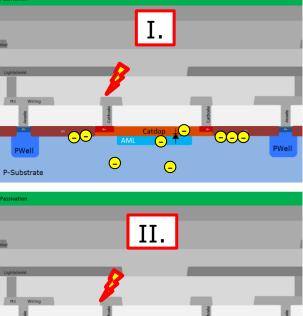
- > Observation over 20 times measure the same device:
  - necessary to determine the breakdown voltage with a sufficient accuracy
  - No clear breakdown, array of curves observed

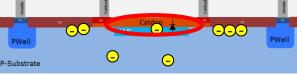
# **Measurement principle**

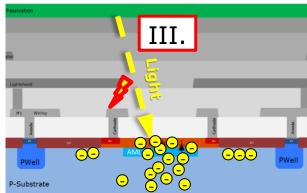
- I. Photodiode mode  $V_{Bias} < V_{BV}$ 
  - Steady measurement
  - Current will be collected from diode surrounding
    - STI interface
    - Trap related
    - Diffusion from Epi material
    - Etc.
- II. Diode breakdown  $V_{Bias} \ge V_{BV}$ 
  - A carrier is needed in the junction where the breakdown occur to trigger the avalanche
  - Time dependent event:
    - If no carrier is triggering; the voltage could further increased until a carrier ignites the avalanche
    - Integration time during the measurement

### III. Diode breakdown under illumination $V_{Bias} \ge V_{BV}$

- Still time dependent domain but:
  - Inducing carriers in the junction by illumination
    - Alternatively by temperature, defects etc.
  - Accurate triggering of the junction breakdown





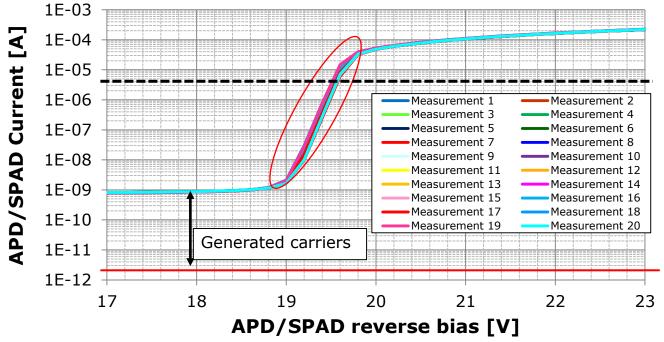




**Current solution (Characterization)** 

- For process control monitoring and characterization an illumination is done to shift the current level
- Increase in the amount of charge carriers
  - With increasing the amount of carriers a proper breakdown can be triggered





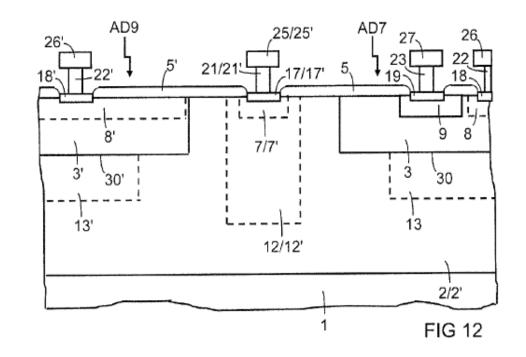
- Current status for the development:
  - Breakdown voltage measurements in lab are done under illumination with an optical fiber
  - For process control monitoring an optical test system was introduced with release of the devices

# **Further solutions**



- Also other groups focus on the topic of breakdown voltage characterization in SPADs:
- SPAD device for excess bias monitoring" from AMS
- > extra high dark count SPAD device to control the excess voltage of the sensor element

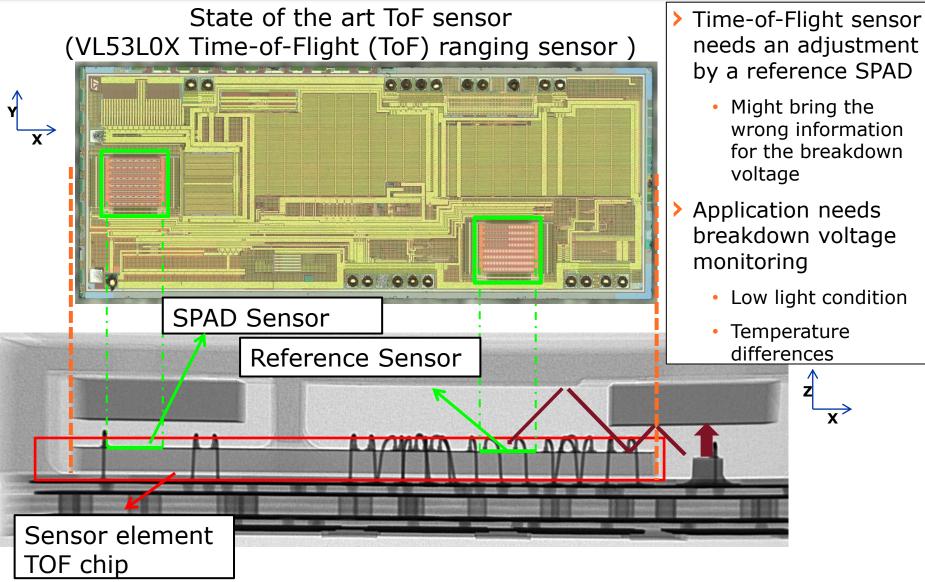
SPAD DEVICE FOR EXCESS BIAS MONITORING



G. Röhrer, et al. "SPAD device for excess bias monitoring" WO 2019/020472 A1, 31 January 2019

# **State of the art sensor Application**







#### Motivation

- > Technical issues on breakdown voltage measurement
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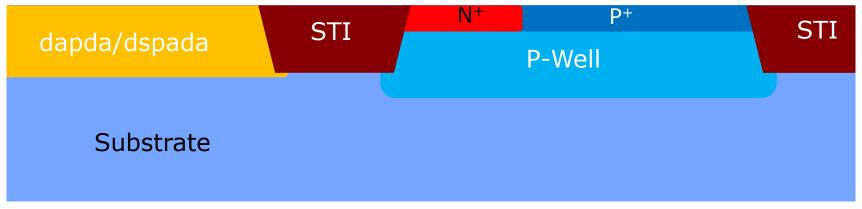
### Functionality principle & simulation study

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# **Functionality principle**



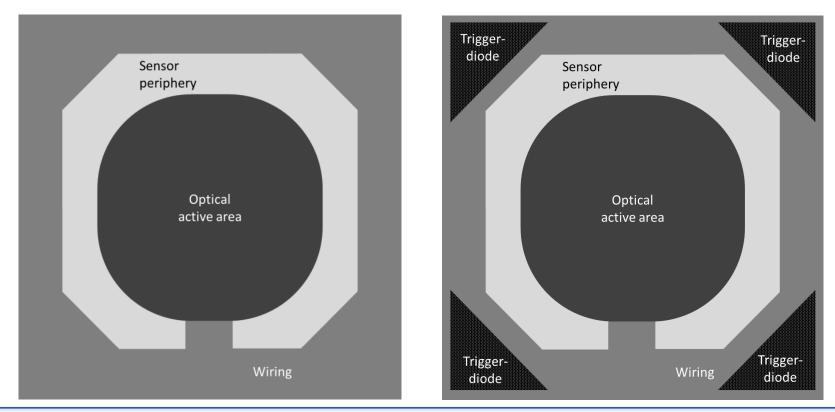
- With a trigger diode the illumination from outside would become obsolete
- Independent method also against breakdown voltage shift caused by different temperatures
  - In-situ measurement and switchable monitoring
- Trigger diode with an additional n<sup>+</sup> implantation
- > Boundary for simulation:
  - Reverse voltage 2.9 V at trigger diode (~1 mA), 0..32 V at Cathode, circular device, no light, 27 °C



# Design

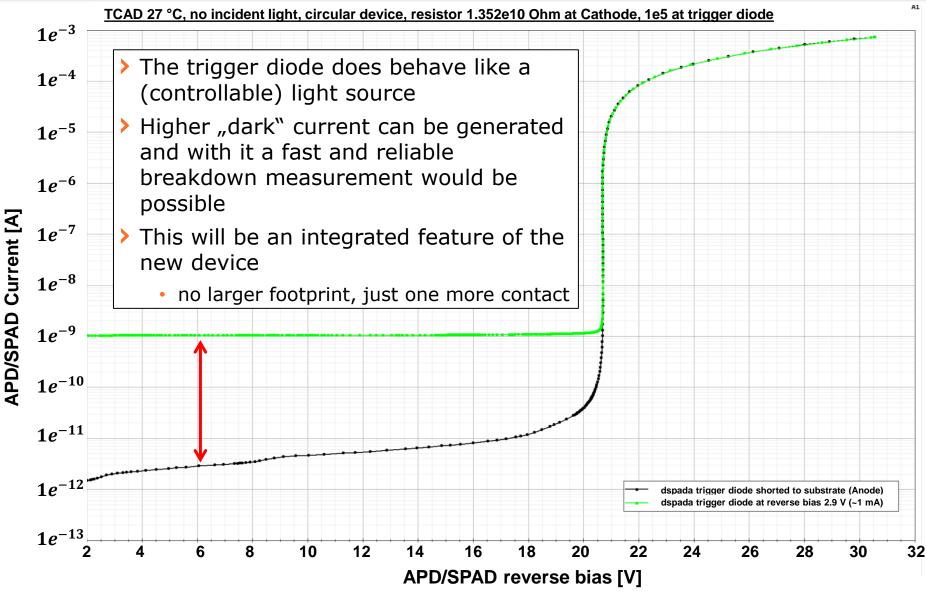


- Compared to the existing design there is no impact on the footprint or the fill factor of the sensor device
- The trigger diode is placed in the corners were no impact is given to the existing design
- > No additional process steps are required



# **Simulation study**



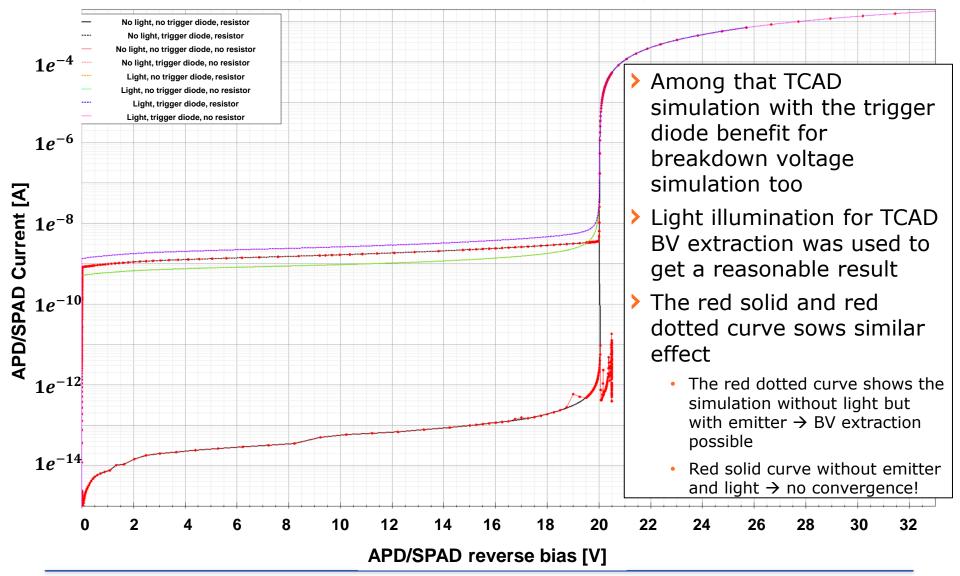


**Company Confidential** 

# **Simulation study**



TCAD at 27 °C, 850 nm light, circular device, 8.4 µm optical active, 2 mA trigger diode at 3.3 V





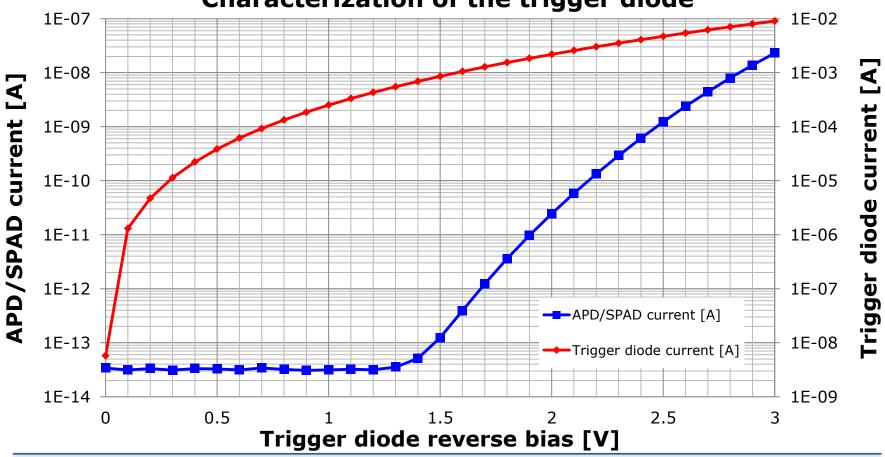
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# **Characterization Results**



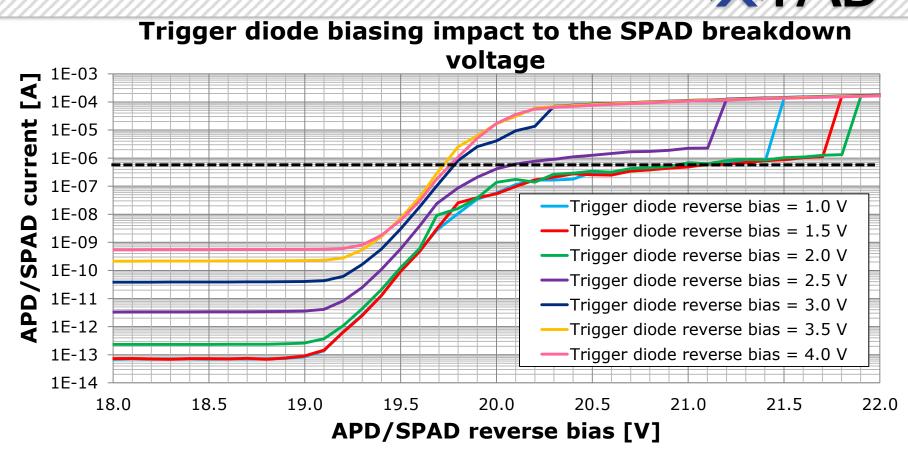
#### Functionality test:

- Implementation to improve the measurement methodology
- Increased APD/SPAD current in dependency to the reverse voltage could be observed



#### Characterization of the trigger diode

# **Characterization Results**

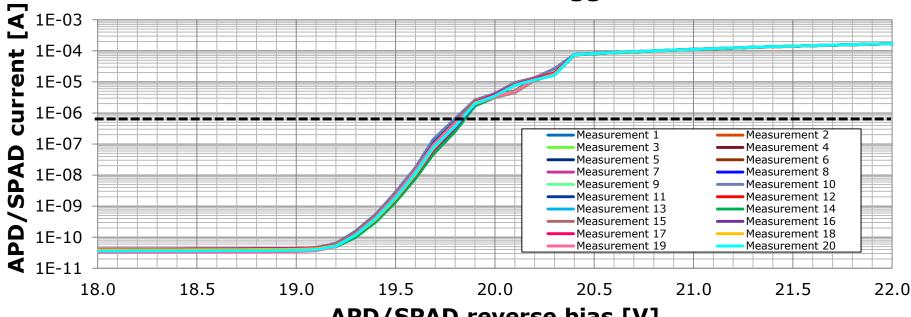


- Furthermore, the impact of the bias voltage of the trigger on the IV-curve and on the breakdown voltage could be observed
  - The higher the reverse bias of the trigger diode the more comparable measurement environment could be placed as the device would be illuminated

## **Characterization Results**



#### Breakdown voltage characterization of dapda/dspada with 3.0 V reverse biased trigger diode



APD/SPAD reverse bias [V]

- Also a characterization of 20 SPAD devices with a reverse bias of 3.0 V shows the improvement of the BV measurement
- It is possible to measure an IV curve and determine the breakdown voltage of small (10 µm) SPAD devices



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# Conclusion



- A new device for breakdown measurements was implemented to improve the breakdown voltage measurement (patent pending)
  - Makes the current solution with illumination during measurement obsolete
- With this new device it is possible to get precise values for the breakdown voltage (two operation modes: BV extraction and sensing)
  - Part to part or temperature related breakdown voltage deviation can be detected without impact on the device (just short timeslot required)
- Beneficial for the usage of avalanche photodiodes and/or single photon avalanche diodes
  - Multiplication control of APDs (precise adaptive bias)
  - Wider range for excess bias on SPAD (excess bias can be exactly regulated)
- No impact to the device footprint, no additional process effort, no impact on the device performance (if trigger diode is unbiased), works stable with low voltage <3 V.</p>



- > Daniel Gäbler for the support around this topic (simulation, design etc.)
- > Hannes Schmidt for characterization support
- > Opto process development team



#### THE MORE THE

Thank you for your attention.